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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

File the Application of: Tetsuya IKUTA et al.

Group Art Unit: 2814

Serial Number: 10/809,809

Examiner: Thao X. Le

Filed: March 26, 2004

Confirmation No.: 7816

For: SEMICONDUCTOR MANUFACTURING
METHOD FOR IMPROVING CARRIER
MOBILITY AND REDUCING LEAK CURRENT
(AS AMENDED)

Attorney Docket Number: 042278
Customer Number: 38834

AMENDMENT UNDER 37 CFR § 1.116

MAILSTOP: AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 9, 2006

D/S
Sir:

This paper is filed in response to the Office Action dated December 9, 2005.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of

T. Le
03/17/06
this paper.

Remarks/Arguments begin on page 9 of this paper.